



IAP15 Rec'd PCT/PTO 15 NOV 2006
PCT

Docket No.: 1220.1001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kenichi SHIRAISHI

Serial No. 10/589,437

Group Art Unit:

Confirmation No.

Filed: August 15, 2006

Examiner:

For: EXPOSURE APPARATUS, SUPPLY METHOD AND RECOVERY METHOD,
EXPOSURE METHOD, AND DEVICE PRODUCING METHOD

SUBMISSION OF DECLARATION

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed is a Declaration for the above-identified application.

A check in the amount of \$130.00 for the declaration surcharge is attached hereto.

Respectfully submitted,

STAAS & HALSEY LLP

Date: November 15, 2006

By: Paul I. Kravetz

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